

Notice of References Cited	Application/Control No. 10/771,453	Applicant(s)/Patent Under Reexamination WATANABE ET AL.	
	Examiner Gabriel L. Chu	Art Unit 2114	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0078508	04-2004	Rivard, William G.	711/004
*	B	US-5,148,432	09-1992	Gordon et al.	714/7
*	C	US-5,166,939	11-1992	Jaffe et al.	714/766
*	D	US-5,341,493	08-1994	Yanai et al.	711/161
*	E	US-5,568,629	10-1996	Gentry et al.	711/114
*	F	US-5,657,468	08-1997	Stallmo et al.	711/114
*	G	US-5,854,942	12-1998	Penokie, George Oliver	710/10
*	H	US-6,487,634	11-2002	Bachmat, Eitan	711/112
*	I	US-6,567,892	05-2003	Horst et al.	711/114
*	J	US-6,571,354	05-2003	Parks et al.	714/7
*	K	US-6,618,798	09-2003	Burton et al.	711/202
*	L	US-6,687,787	02-2004	Richardson et al.	711/114
*	M	US-6,857,059	02-2005	Karpoff et al.	711/209

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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